



Docket No. 0524-0139.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Nozawa et al.

Serial No.: 10/771,997

Filed: February 4, 2004

For: Manufacturing Method And Apparatus of  
Phase Mask Shift Blank

Examiner: Steven Versteeg

Art Unit: 1753

I hereby certify that this correspondence is being  
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Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450 on

July 7, 2005  
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 7/7/05  
Signature Date

AMENDMENT C (AFTER FINAL)

Commissioner of Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Rejection of March 9, 2005, a one month extension of time being  
submitted herewith, please enter the following amendment in the above-identified application: